

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of
Shigehiro NISHINO et al.

Rec'd PCT/PTO 03 FEB 2005

Application No.: 10/520,141

Filed: January 3, 2005

Docket No.: 122261

For: LARGE-DIAMETER SIC WAFER AND MANUFACTURING METHOD THEREOF

INFORMATION DISCLOSURE STATEMENT

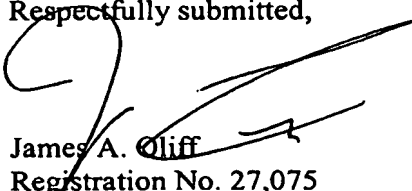
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of the non-English language reference 2 is discussed in the present specification.
- ☒ 3. The references are cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information.
- ☒ 4. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- ☒ 5. English language Abstracts of the non-English language references are attached hereto.
- ☒ 6. Computer-generated English language translations of the following Japanese references have been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and are attached, but have not been reviewed for accuracy. See References 2-3.
- ☒ 7. References 1 and 3 correspond to EP 916750 A1.

Respectfully submitted,


James A. Oliff
Registration No. 27,075
Jesse O. Collier
Registration No. 53,839

JAO:JOC/nxy

Date: February 3, 2005

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 122261	APPLICATION NO. 10/520,141
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Shigehiro NISHINO et al.	
				FILING DATE January 3, 2005	

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
/MS/	1.	6,053,973	04/25/2000	Kichiya TANINO et al.		

FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
/MS/	2.	JP-A-10-055975 w/ abst. & trans.	02/24/1998	JAPAN		
/MS/	3.	JP-A-11-147794 w/ abst. & trans.	06/02/1999	JAPAN		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)		

EXAMINER /Matthew Song/	DATE CONSIDERED 06/05/2007
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Date: February 3, 2005

IFW



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Shigehiro NISHINO et al.

Group Art Unit: 1722

Application No.: 10/520,141

Filed: September 1, 2005

Docket No.: 122261

For: LARGE-DIAMETER SIC WAFER AND MANUFACTURING METHOD THEREOF

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


Sir:

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- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. One or more reference cited herein was cited in a counterpart foreign application. An English language version of the foreign Office Action is attached for the Examiner's information. See Reference 2.
- ☒ 3. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- ☒ 4. Reference 1 corresponds to reference 2.

- ☒ 5. References EP 0916750 and JP 10-055975 are listed in the Office Action, but were previously disclosed in an Information Disclosure Statement filed on February 3, 2005.

Respectfully submitted,


James A. Oliff
Registration No. 27,075

Randi B. Isaacs
Registration No. 56,046

JAO:RBI/aha

Date: May 15, 2007

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

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Sheet 1 of 1

Form PTO-1449 (REV. 1/06) US Dept. of Commerce PATENT & TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	ATTY DOCKET NO. 122261	APPLICATION NO. 10/520,141
	APPLICANT(S) Shigehiro NISHINO et al.	
	FILING DATE September 1, 2005	GROUP 1722

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number	Date	Name
/MS/	1	6,203,772 B1	03/20/2001	Tanino et al.

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation
/MS/	2	RU 2 154 698 C2	08/20/2000	RUSSIA		

OTHER DOCUMENTS

Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)

EXAMINER /Matthew Song/	DATE CONSIDERED 06/05/2007
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Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Date: May 15, 2007